

Docket No.: 1592-0164PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Eiichi SHIMIZU et al.

Application No.: 10/589,348

Confirmation No.: 8171

Filed: August 11, 2006

Art Unit: 1792

For: VAPOR PHASE GROWTH APPARATUS

Examiner: R. N. Kackar

AMENDMENT AFTER NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

INTRODUCTORY COMMENTS

In response to the Office Action dated April 6, 2009, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.